



IFW

PATENT  
Docket No. 20063/OG03-011

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Cho, et al.	)	Title: "Methods of Fabricating a
	)	MOSFET"
Serial No: 10/627,418	)	
	)	
Filed: July 25, 2003	)	Group Art Unit: 2818
	)	
	)	Examiner: Nhu

**TRANSMITTAL OF FORMAL DRAWINGS**

Mail Stop Drawing Review  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

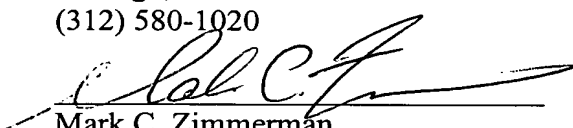
Sir:

Enclosed herewith are two replacement sheets (FIG. 1a-d) of formal drawings for the above-referenced application.

Respectfully submitted,

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By:

  
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August 9, 2004

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**CERTIFICATE OF MAILING (37 CFR 1.8)**

I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, on **August 9, 2004**, in an envelope addressed to the Mail Stop Drawing Review, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

  
Mark C. Zimmerman